

F rm 1449 (Modifi d)

Informati n Disclosure Stat m nt By Applicant

(Use Several Sheets if Necessary)

Attorney Docket No:

LAM1P106.A

Applicant:

Jay E. Uglow et al.

Filing Date: February 16, 2001

te: Group:

Unassigned

U.S. Serial No:

-Unassigned

**U.S. Patent Documents** 

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	Examiner						Sub-		Filing	
	Initial	No.	Patent No.	Date	Patentee	Class	class		Date	<u> </u>
gh	TSP	Α	5,821,168	10/13/1998	Jain	438	692	7/97		▋
M	158	В	5,960,320	09/28/1999	Park	438	688	13.2	<b>※ 8 =</b>	<u></u>
m	TSP	С	5,904,565	05/18/1999	Nguyen et al.	438	687	I Po	S 59	12
me	758	D	5,705,430	01/06/1998	Avanzino et al.	438	195			■7
me	TSP	Е	5,969,422	10/19/1999	Ting et al.	257	762	بر غر در	<b>倒光8</b>	<b>≣</b> 2
Mis	TSP	F	5,635,423	06/03/1997	Huang et al.	437	195	10/44	ot 	<b>手</b>
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Foreign Patent or Published Foreign Patent Application

	Examiner	1	Document	Publication	Country or		Sub-	Trans	lation
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ŋ	13P	L	00/10202	02/2000	WIPO		-		
9	TSP	М	0834916	04/1998	EPO				
6		N	0945900A1	03/1999	EPO				
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		Р							

**Other Documents** 

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
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Examiner		Date Considered
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Form 1449 (Modified)

Information Disclosure Statement By Applicant

(Use Several Sheets if Necessary)

Attorney Docket No: LAM1P106.A U.S. Serial No: 09/785,999

Applicant:

Jay E. Uglow et al.

Filing Date: February 16, 2001 Group: 2813\_\_\_\_

**U.S. Patent Documents** 

	Examiner Initial	No.	Patent No.	Date	Patentee	Class	class_	Date
5	137	A	6,287,955	09/11/2001	WANG et al.			
b	TSP	В	6,025,273	02/15/2000	CHEN et al.			
زو		c	6,165,898	12/26/2000	JANG et al.			
j		Ď	5,858,869	01/12/1999	CHEN et al.			
<u></u>		Ē	6,069,058	05/30/2000	HONG		<del> </del>	
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Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub- class	Yes	No
PTSP	L.	DE19904311	08/12/1999	German Patent Office			-	<del> </del>
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Informati n Disclosure Statement By Applicant

(Use Several Sheets if Necessary)

Attorney Docket No:

LAM1P106.A

U.S. Serial No: 09/785,999

Applicant:

Jay E. Uglow et al.

Filing Date:

Group:

February 16, 2001

2813

**U.S. Patent Documents** 

				U.S. Pale	ent Documents			
	Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date
7,		140.				Ciass	Ciass	Date
The		A	6,054,379	04/2000	YAU et al.			
722	5 150	В	6,211,063	04/2001	LIU et al.			
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Foreign Patent or Published Foreign Patent Application

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**Other Documents** 

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
No. Author, Title, Date, Place (e.g. Journal) of Publication  R WOLF et al., "Silicon Processing for the VLSI Era Volume 1: Process Technology," Lattice Press, 1986, (3 pages) pp 1924  S  T  Cleant Man Al 1/27/06		
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Complete if Known

Application Number 09/785,999

Filing Date February 16, 2001

First Named Inventor Jay Uglow

Art Unit 2813

Examiner Name Kielin, Erik J.

Attorney Docket Number LAM1P106A

(Use as many sheets as necessary)

Sheet 1 of 1

## **U.S. Patent Documents**

Examiner Initials	Cite No.¹	Document Number  Number-Kind Code <sup>2 (ff known)</sup>	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear
Anis	Α	6,297,163-B1	10/02/2001	Zhu et al.	·
mis	В	2002/0054962-A1	05/09/2002	Huang	
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**Foreign Patent Documents** 

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7		Country Code <sup>3</sup> -Number- <sup>4</sup> Kind Code <sup>5(if known)</sup>		Cited Document	Relevant Figures Appear	
	М					
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	Р					
	Q					

## **Non Patent Literature Documents**

Examiner Initial	Cite No.	Include name of author (in CAPTIAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published				
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Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

<sup>&</sup>lt;sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kinds Codes of USPTO Patent Documents at <a href="www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. <sup>3</sup>Enter Office that issued the document, by two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached.